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Selective A- or B-site single termination on surfaces of layered oxide SrLaAlO$_4$

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We demonstrate that thermal annealing in cation controlled environments is an effective means to obtain atomically flat and chemically single terminated surfaces of a layer structured substrate. The effectiveness of the cation controlled annealing method is proved with SrLaAlO$_4$, which is a representative layer structured substrate of A$_2$BO$_4$ type. Potassium ion scattering, in particular, shows that the method allows not only single termination but also selective termination of either A- or B-site on the substrate. We further demonstrate that the chemical nature of underlying SrLaAlO$_4$ substrates is of critical importance in the growth of SrRuO$_3$ thin films resulting in different morphologies and transport properties. © 2013 American Institute of Physics.

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Advances in epitaxial growth of oxide thin films, allowing precise control of the interfaces on atomic scale, have led to the discovery of termination dependent interface phenomena such as two dimensional electron gas, superconductivity, and magnetism.1,2 An essential prerequisite for high quality oxide epitaxy is, of course, the availability of atomically flat and chemically single terminated substrates.3 Traditional substrate treatments to obtain single terminated surfaces have been limited to ABO$_3$ type simple perovskites such as SrTiO$_3$,4,5 DyScO$_3$,6 NdGaO$_3$,7 and La$_{0.11}$Sr$_{0.89}$AlO$_2$TaO$_{4+2}$.8 Currently, activities in surface controlled epitaxial growth and interface phenomena of oxide thin films utilize these perovskites, in particular, SrTiO$_3$. The availability of atomically flat and chemically single terminated substrates of layered structure, however, would enrich the study of oxide thin films and heterostructures and allow exploration of new interfacial functionalities. The purpose of the present work is to show that it is indeed possible to obtain an atomically flat surface with single termination on a layered substrate of A$_2$BO$_4$ type; we demonstrate that annealing SrLaAlO$_4$ substrates in proper cation environments is an effective means to create atomically flat surfaces with chemically selective single termination.

SrLaAlO$_4$ substrates are of great importance as their (001) surface provides a relatively small in-plane lattice constant of 3.7569 Å and thus would be useful in engineering functionality in oxide films with strain effects.9,10 SrLaAlO$_4$ would be of value as an insulating substrate because it maintains insulating nature even under prolonged exposure to reducing conditions. Many substrate materials including SrTiO$_3$ lose their insulating property when exposed to low oxygen pressures and high temperatures for an extended time.11 SrLaAlO$_4$ is also useful as a substrate for growing high $T_c$ superconductors. The superconducting $T_c$ of epitaxial films of La$_{1.9}$Sr$_{0.1}$CuO$_4$ deposited on this substrate reaches 49 K, phenomenally doubling the bulk value of 25 K.12 For YBa$_2$Cu$_3$O$_{7-δ}$ films grown on the same substrate, non-unit cell growth frequently occurs;13 it was suspected that this might be related to the chemistry of the substrate surface, but still remains unresolved.

From a structural point of view, SrLaAlO$_4$ crystallizes in a tetragonal layered K$_2$NiF$_4$ structure with lattice constants $a = b = 3.7569$ Å and $c = 12.6362$ Å and space group $I4/mmm$.14 This compound contains AlO$_6$ octahedra, whereas Sr/La is surrounded only by nine oxygen. The sequence of atomic planes along the c-axis may be represented as --AlO$_2$-(Sr,La)$_2$O-(Sr,La)$_2$O-AlO$_2$-(Sr,La)$_2$O-- as illustrated in Fig. 1(a); the (Sr,La)$_2$O planes are regarded as the A-site layer and the AlO$_2$ planes as the B-site layer. Despite well known as an oxide substrate with high chemical stability, there have been very few surface studies on this substrate. One report shows that upon annealing in oxidizing conditions, SrO segregates on the surface as particles in combination with holes, creating significant surface roughness.15 Moreover, the polar nature of the atomic layers and the absence of preferential etchant for (Sr,La)$_2$O and AlO$_2$, make termination control extremely challenging.

The SrLaAlO$_4$ (001) single crystals ($10 \times 10$ mm$^2$) used in the experiment were commercially available ones provided by Crystec, GmbH, Germany; the AFM image of the (001) surface of an as-received crystal is shown in Fig. 1(b) (RMS roughness $\sim$1 nm), which presumably has mixed surface termination. Annealing the crystal at 1000 °C for 2 h results in the formation of particles of size 10–50 nm on the surface and particularly on the step edges as displayed in Fig. 1(c). It may be noted that similar particle formation was previously seen in several oxides.8,15,16 These particles are soluble in de-ionized water and disappear after soaking for 10 min as Figure 1(d) indicates, and thus they are most likely
SrO particles because other possible oxide particles such as La$_2$O$_3$ and Al$_2$O$_3$ are insoluble in water. But this soaking procedure results in increased roughness (RMS roughness $\sim$2 nm), and deteriorates the substrate surface quality.

The formation of SrO particles on the SrLaAlO$_4$ (001) surface upon annealing suggests the loss of other cations such as La or Al or both from the surface. While the process leading to the SrO formation would be governed by a complex interplay between kinetics and thermodynamics and would be difficult to follow, one may be able to identify experimentally the cations evaporating most from the surface. In Fig. 2(a), the experimental arrangement for this purpose is shown; SrLaAlO$_4$ (001) substrate is surrounded with La$_2$O$_3$ or Al$_2$O$_3$ powder as slabs, and thus we provide cation rich annealing environments. It is noted that this cation rich annealing method was previously used for perovskite La$_{0.18}$Sr$_{0.82}$Al$_{0.59}$Ta$_{0.41}$O$_3$ substrates, leading to A-site termination only.$^8$ After prebaking the powder, the whole setup (substrate + powder) is then annealed. When annealing for 2h at 1000 °C in a La$_2$O$_3$ environment, atomically flat surfaces are created without any SrO particles, as evidenced by the AFM images of Figs. 2(b) and 2(c), with a half unit cell step height (0.63 nm) and terrace width $\sim$250 nm. In contrast to the La$_2$O$_3$ case, the same thermal treatment with Al$_2$O$_3$ in place of La$_2$O$_3$ neither prevents the formation of SrO particles nor gives an atomically flat surface. (shown in supplemental material).$^{21}$ Therefore, we conclude that La loss from the surface induces SrO particle formation and La compensation is essential for obtaining atomically flat surfaces.

Having identified La as the key element in achieving structurally well ordered surfaces of SrLaAlO$_4$, we now turn to another critical issue, that is, the chemical nature of the atomically flat surfaces. At first glance, the half unit cell steps found in the AFM measurements and the layered crystal structure itself naturally suggest that the topmost surface...
layer would be single terminated with (Sr,La)O, i.e., A-site terminated. These considerations, however, may not necessarily exclude a possibility of B-site termination in case Al ions are supplied simultaneously with La ions in the surrounding vapor during the annealing process. To check this possibility, however mere it is, an attempt was made to use a LaAlO$_3$ crystal as a vapor source. A LaAlO$_3$ crystal was placed in close proximity to the surface of SrLaAlO$_4$ (0.22 mm gap between the surfaces) with polished side facing each other as shown in Fig. 2(d); the whole setup is then annealed at 1000 °C for 2h. Fig. 2(e) is the obtained AFM image after annealing the SrLaAlO$_4$ (001) surface, and it shows that the surface is atomically flat with the step height of ~0.63 nm and terrace width of ~250 nm as seen in Fig. 2(f). Thus, we have achieved equal structural successes both with La$_2$O$_3$ and with LaAlO$_3$ as background cation sources in the annealing treatments of SrLaAlO$_4$ (001) substrates. Moreover, these treated substrates (10 × 10 mm$^2$, thickness 0.5 mm) were found to remain insulating with resistance larger than 10$^{10}$ Ω when exposed to reducing conditions of 900 °C and O$_2$ pressure of 10$^{-7}$ Torr for several hours. The remaining task is to examine and identify the chemical nature of the topmost layers of the thermally treated crystals.

In order to identify the topmost atomic layer, we employed angle resolved mass spectroscopy of recoiled ions (AR-MSRI) analysis along with direct recoil spectroscopy (DRS) to determine the surface termination of as-received and treated substrates. For scattering purposes, pulsed potassium (39K) ions with a kinetic energy of 10 keV are injected on the surface of the substrates at an incident angle of 15°, scattered and recoiled species from the sample are collected at 25° using a multichannel plate detector for DRS and 60° using a reflectron analyzer for MSRI as illustrated in the inset of Fig. 3. All the AR-MSRI and DRS (Ionwerks, Inc.) measurements were conducted in high vacuum (10$^{-7}$ Torr) at 150 °C. Prior to the measurements, the substrates were annealed at 600 °C in 50 mTorr of oxygen gas to remove hydrocarbon contaminations. In general, [100] and [010] correspond to ±0° and ±90° of the azimuth and [110] as ±45° and ±135° of the azimuth. The kinetic energy of recoiled atoms is proportional to their mass, allowing a direct conversion from time of flight to atomic mass. The intensities of recoiled ions are naturally influenced by neighboring ions and their arrangements; the variation of recoiled intensities and their ratios as a function of azimuthal angle is commonly used to evidence single terminated surfaces for perovskite oxides, particularly along the [110] direction where the A-site and B-site cations shadow one another. However, it should be kept in mind that SrLaAlO$_4$ is not an actual perovskite but a layered one. The (Sr,La)O double layer of the system has a [1/2/1/2/0] displacement, which permits blocking and shadowing effects in [100] and [010] directions as well as [110] direction.

In Fig. 3, the Al/(Sr + La) ratio extracted from the AR-MSRI measurements is shown for the three SrLaAlO$_4$ substrates, as-received one (black circles) and annealed ones in La$_2$O$_3$ (green circles) and LaAlO$_3$ (pink circles) environments. The signal from the as-received sample is regarded as the reference, and the signals from the treated samples are compared with the reference because the as-received sample is expected to have mixed termination. For the La$_2$O$_3$ treated sample (green circles), it is seen that there is an overall decrease in the Al/(Sr + La) ratio intensity from the reference values (black circles), and the most severe reductions from the reference occur in the low index crystalline directions such as 0°, ±90°, and ±45° angles, corresponding to [100], [010], and [110] directions, respectively. These features, in particular, the reduction in the [110] direction, indicate (Sr,La)O as the topmost layer of the La$_2$O$_3$ treated sample. For the LaAlO$_3$ treated sample, on the other hand, an overall increase in the Al/(Sr + La) intensity is observed with the exception of 0° and ±90°, [100] and [010] directions, respectively, in Fig. 3. The largest increase is seen at ±45°, or in the [110] direction, and this corresponds to shadowing of (Sr,La) by Al, indicating AlO$_2$ as the topmost layer. The behaviors at 0° and ±90° suggest that (Sr,La)O is the second layer.

For further insight in the cation arrangements of the top layers, individual cation ratios again extracted from the AR-MSRI measurements are given in Fig. 4. It may be noted that the Al/Sr and Al/La ratios for the as-received substrate show the more or less same variation as a function of azimuthal angle as the Al/(Sr + La) ratio of the same sample, while the Sr/La ratio shows almost no variation. These features indicate that there is a good mixing of Sr and La in the (Sr,La)O layer on the surface. The occurrence of distinctive minima in the Al/Sr ratio of the La$_2$O$_3$ treated sample in [110] as well as [010] and [100] directions, as shown in Fig. 4(a), is the evidence of shadowing of Al by two layers of Sr thus confirming (Sr,La)O as top layer. The low intensity peaks for all low index crystalline directions for the Al/La ratio in Fig. 4(b) suggest that there is a negligible amount of La on top of the first AlO$_2$ layer. The LaAlO$_3$ treated sample also has increased values for the Al/Sr ratio and a strong maximum for the Al/La ratio in the [110] direction; this indicates shadowing of both La and Sr by Al and therefore evidencing

![Graph](image-url)

FIG. 3. The ratio of the Al signal against the sum of the Sr and La signals from AR-MSRI is shown for substrates as they were received (black) and annealed at 600 °C in 50 mTorr of oxygen gas to remove hydrocarbon contaminations. In general, [100] and [010] correspond to ±0° and ±90° of the azimuth and [110] as ±45° and ±135° of the azimuth. The kinetic energy of recoiled atoms is proportional to their mass, allowing a direct conversion from time of flight to atomic mass. The intensities of recoiled ions are naturally influenced by neighboring ions and their arrangements; the variation of recoiled intensities and their ratios as a function of azimuthal angle is commonly used to evidence single terminated surfaces for perovskite oxides, particularly along the [110] direction where the A-site and B-site cations shadow one another. However, it should be kept in mind that SrLaAlO$_4$ is not an actual perovskite but a layered one. The (Sr,La)O double layer of the system has a [1/2/1/2/0] displacement, which permits blocking and shadowing effects in [100] and [010] directions as well as [110] direction.

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AlO$_2$ to be the topmost layer. The minimum in both Al/Sr and Al/La ratios in the [010] direction indicates only a single layer of AlO$_2$ at the top. Fig. 4(c) shows that strong maxima along the [110] direction exist in the Sr/La ratio for both La$_2$O$_3$ treated and LaAlO$_3$ treated substrates, indicating that the annealing process results generally in somewhat La-poor (Sr,La)O layers at the surface, as compared to the as-received substrate. This shows that despite the presence of La rich environments, high temperature annealing processes invariably create La depleted surfaces.

Additional confirmation of the surface termination can be obtained from the DRS analysis of the scattered potassium ion intensities, $K_s$(Sr,La) and $K_s$(Al) scattered from heavy (Sr, La) and light (Al) elements, respectively. (Cationic analysis of the DRS spectra is given in supplemental material.)$^{21}$ The analysis shows that there is an overall increase in $K_s$(Sr,La) for the La$_2$O$_3$ treated sample compared to the as-received or LaAlO$_3$ treated case, indicating (Sr,La)O as the topmost layer as shown in Fig. 5(a). On the other hand, Fig. 5(b) shows contrasting overall increase in the intensity of $K_s$(Al) for the LaAlO$_3$ treated sample, indicating AlO$_2$ as the topmost layer. Thus, judging from the AR-MSRI results with further support from the DRS data, we are led to the (Sr,La)O-(Sr,La)O-AlO$_2$ layer sequence from the surface, with the La poor topmost layer, for the La$_2$O$_3$ treated sample, and to the AlO$_2$-(Sr,La)O-(Sr,La)O layer sequence, where the first (Sr,La)O is likely to be La poor, for the LaAlO$_3$ treated sample.

While we have determined the topmost terminating layer of SrLaAlO$_4$ substrates by various probing techniques, thin film growth itself may be used as a way to ascertain different terminations. For this purpose, we chose SrRuO$_3$ as an oxide material to grow on the treated substrates; it was seen earlier that SrRuO$_3$ tends to grow preferably on B-site terminated surfaces of SrTiO$_3$ substrates.$^{19}$ Thin films of 30 nm were grown at 700 °C with oxygen partial pressure of 10 mTorr and laser pulses at 2 Hz, using a KrF laser ($\lambda = 248$ nm). After growth samples were slowly cooled down in oxygen environments. Figs. 6(a) and 6(b) show the morphology of films grown on a (Sr,La)O terminated substrate and an AlO$_2$ terminated substrate, respectively. Array of large trenches is visible for films grown on (Sr,La)O terminated substrates. It may be noted that deep trenches were previously observed when SrTiO$_3$ substrates had SrO termination in addition to TiO$_2$ termination.$^{20,21}$ Contrasting morphologies in the figure clearly exhibit termination dependent

![Fig. 4](https://example.com/fig4.png)

**FIG. 4.** Individual cation ratios extracted from the AR-MSRI measurements are shown. (a) The ratio between Al and Sr. (b) The ratio between Al and La. (c) The ratio between Sr and La. These data provide further insight in the cation arrangements of the top layers, and reveal La poor layers for annealed substrates.

![Fig. 5](https://example.com/fig5.png)

**FIG. 5.** Relative intensities from the DRS spectra are shown for potassium scattered off (Sr,La) in (a) and off Al in (b), designated as $K_s$(Sr,La) and $K_s$(Al), respectively. The $K_s$(Sr,La) intensity is significantly higher for the La$_3$O$_5$ surrounded sample than others, indicating (Sr,La)O termination. The $K_s$(Al) intensity is significantly higher for the LaAlO$_3$ covered sample, indicating AlO$_2$ termination.

![Fig. 6](https://example.com/fig6.png)

**FIG. 6.** AFM images of SrRuO$_3$ films grown on different terminated substrates; (a) (Sr,La)O termination, (b) AlO$_2$ termination. For the film grown on (Sr,La)O terminated substrate, clear nm sized trenches are visible, which are absent for that on AlO$_2$ terminated substrate; this selective growth preference of SrRuO$_3$ confirming different substrate terminations. (c) Resistivity of the two samples showing morphology dependent transport behavior.
growth of SrRuO$_3$ films. Resistivity measurements also show a strong dependence on growth morphology as is seen in Fig. 6(c). These behaviors indicate that we have selective termination of either (Sr,La)O or AlO$_2$ on SrLaAlO$_4$ substrates, and growth of oxide thin films is sensitive to the chemical nature of the top surface. The availability of atomically flat and chemically single terminated substrates beyond simple perovskites would broaden the research horizon for oxide epitaxy and interface phenomena.

In conclusion, the present work demonstrated that annealing a substrate in proper cation environments is an effective means to create atomically flat surfaces with selective termination of A- or B-type in a common substrate such as SrLaAlO$_4$. The detailed AR-MSRI and DRS measurements were used to confirm that the layer sequences for La$_2$O$_3$ and LaAlO$_3$ treated SrLaAlO$_4$ substrates are (Sr,La)O-(Sr,La)O-AlO$_2$ and AlO$_2$-(Sr,La)O-(Sr,La)O from the surface, respectively. SrRuO$_3$ films grown on SrLaAlO$_4$ substrates showed termination dependent morphology and transport behaviors. While the present work provides a pathway for obtaining both A- and B-site terminated atomically flat A$_2$B$_2$O$_6$ type layered oxide surfaces, our theoretical understanding of the processes occurring during the annealing treatments is limited. Further investigations, experimental as well as theoretical, are clearly needed to generalize the method to more diverse systems. It should be noted that the ability to singly terminate a substrate surface selectively with atomic flatness without depositing a top layer is of critical importance for the advancement of high quality oxide thin films and heterostructures, which in turn would provide a platform for studying the physics of interface phenomena, high $T_c$ superconductors, polar and non-polar surface reconstructions, advanced device applications, etc.


21. See supplementary material at http://dx.doi.org/10.1063/1.4790575 for optimized annealing treatments and DRS spectra analysis.